



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Sandhu et al.

Serial No.: 10/637,107

Filed: August 8, 2003

For: LOW RESISTANCE CONTACT TO SILICON HAVING A TITANIUM SILICIDE INTERFACE AND AN AMORPHOUS TITANIUM CARBONITRIDE BARRIER

LAYER

Confirmation No.: 5081

Examiner: M. Wilczewski

Group Art Unit: 2822

Attorney Docket No.: 2269-3264.5US

(92-0280.08/US)

Notice of Allowance Mailed:

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Person making Deposit: Steven P. Wong

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Abstract appear on page 7 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 8 of this paper.

Remarks begin on page \square of this paper.